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BIB DATA SHEET

CONFIRMATION NO. 5334

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		435	1795	1795		12732-171001	
	RULE						
APPLICANTS Masaharu Nagai, Kanagawa, JAPAN; Kiyofumi Ogino, Kanagawa, JAPAN; Teruhisa Nakai, Tochigi, JAPAN; Eiji Shioda, Tochigi, JAPAN; ** CONTINUING DATA **********************************							
Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and /DABORAH (DAVIS/ Acknowledged Examiner's Sig	CHACKO	state or country JAPAN	SHEETS DRAWINGS	TOTAL CLAIMS		INDEPENDENT CLAIMS	
ADDRESS							
FISH & RICHARDSON P.C. P.O. BOX 1022 MINNEAPOLIS, MN 55440-1022 UNITED STATES							
TITLE							
Method for removing resist pattern and method for manufacturing semiconductor device							
			☐ All Fe	☐ All Fees			
LEEC. A	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:			☐ 1.16 Fees (Filing)			
				☐ 1.17 Fees (Processing Ext. of time)			
				☐ 1.18 Fees (Issue)			
				☐ Other			
				☐ Credit			